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PATENT & TRADEMARK OFFICE

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Date November 21, 2006 Signature: Michelle Jacobson
(Michelle Jacobson)

Docket No.: 60803 (49381)
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Kazuya Fujita et al.

Application No.: 10/773,809

Confirmation No.: 8452

Entered w/
RCE
dtd 4/21/06

Filed: February 5, 2004

Art Unit: 2814

DMK
12/6/06

For: SOLID STATE IMAGING DEVICE,
SEMICONDUCTOR WAFER, OPTICAL
DEVICE MODULE, METHOD OF SOLID
STATE IMAGING DEVICE FABRICATION,
AND METHOD OF OPTICAL DEVICE
MODULE FABRICATION

Examiner: W. S. Louie

AMENDMENT AFTER FINAL ACTION UNDER 37 C.F.R. 1.116

MS RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Final Office Action dated June 26, 2006, please enter the following amendment, as this amendment is being filed along with a Request for Continued Examination (RCE):

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 9 of this paper.